



<b>SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449</b>	DOCKET NO. 52433/775	SERIAL NO. 10/509,925
	APPLICANT Tetsuro NOSE et al.	
	FILING DATE October 1, 2004	GROUP Not Yet Assigned

## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE	NAME	CLASS	SUBCLASS	FILING DATE*

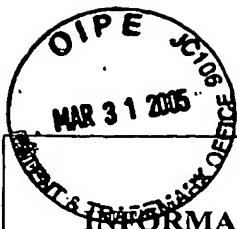
## FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
KEG	EP 0 338 718 A	October 25, 1989	Europe			English Document	
KEG	EP 0 654 456 A	May 24, 1995	Europe			English Document	

## OTHER DOCUMENTS

EXAMINER INITIAL		AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
KEG		Mamoru Mitomo et al. "Stability of $\alpha$ -Sialons in Low Temperature Annealing" Journal of the European Ceramic Society Elsevier UK, vol. 19, no. 1, 1999, pages 7-15.
KEG		Patent Abstracts of Japan, JP 07165462 A, June 27, 1995.

EXAMINER /Karl Group/	DATE CONSIDERED 11/16/2006
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						Yes	No
KEG	8-164452	June 25, 1996	Japan			Abstract	
↓	8-243689	September 24, 1996	Japan			Abstract	
↓	8-243690	September 24, 1996	Japan			Abstract	
↓	8-243691	September 24, 1996	Japan			Abstract	
↓	2001-150106	June 5, 2001	Japan			Abstract	

## OTHER DOCUMENTS

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